



Attorney's Docket No.: 42390P10059CD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Ilan Gavish, et al.

Serial No.: 10/632,582

Filed: July 31, 2003

For: **FOCUSED ION BEAM DEPOSITION**

Examiner: Parviz Hassanzadeh

Art Group: 1763

Confirmation No.: 5004

*DO NOT Enter
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2-10-05*

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Final Office Action mailed November 8, 2004 , Applicants respectfully request entry of the amendments set forth below and consideration of the remarks that follow.

*Entered with
RCE 51915
MW 511215*